

02/14/03

Docket No. 212/361

1765
#5
02/25/03

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

In re Application of:

Kassir, Salman M.

Serial No.: 10/059,701

Filed: January 29, 2002

For: Method of Spin Etching
Wafers With an Alkali
Solution

Art Unit: 2812

Examiner: unassigned

Substitute Drawings

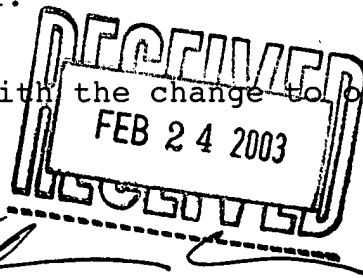
Assistant Commissioner For Patents
Office of Initial Patent Examination
Customer Service Center
Washington, D.C. 20231

RECEIVED
FEB 20 2003
TC 1700 MAIL ROOM

Sir:

Enclosed please find the following [4] sheets of drawings
for U.S. Patent Application No. 10/059,701.

Please charge any fee associated with the change to our
deposit account 03-3700.



Date: February 12, 2003

By:

K. David Crockett, Esq.
Reg. No. 34,311

Certificate of Mailing (37 CFR 1.10)

I hereby certify that this Transmittal (along with any paper referred to as being attached or enclosed) is being deposited Express Mail using Express Mail Post Office to Addressee with the United States Postal Service on the date shown below in an envelop addressed to the Assistant Commissioner of Patents, Office of Initial Patent Examination, Customer Service Center, Washington, D.C. 20231.

Express Mail Label No. EL805376501US
Date: February 12, 2003

Venus Pelayo
Venus Pelayo

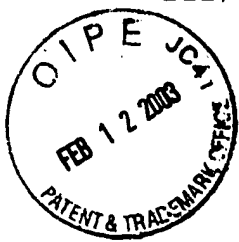
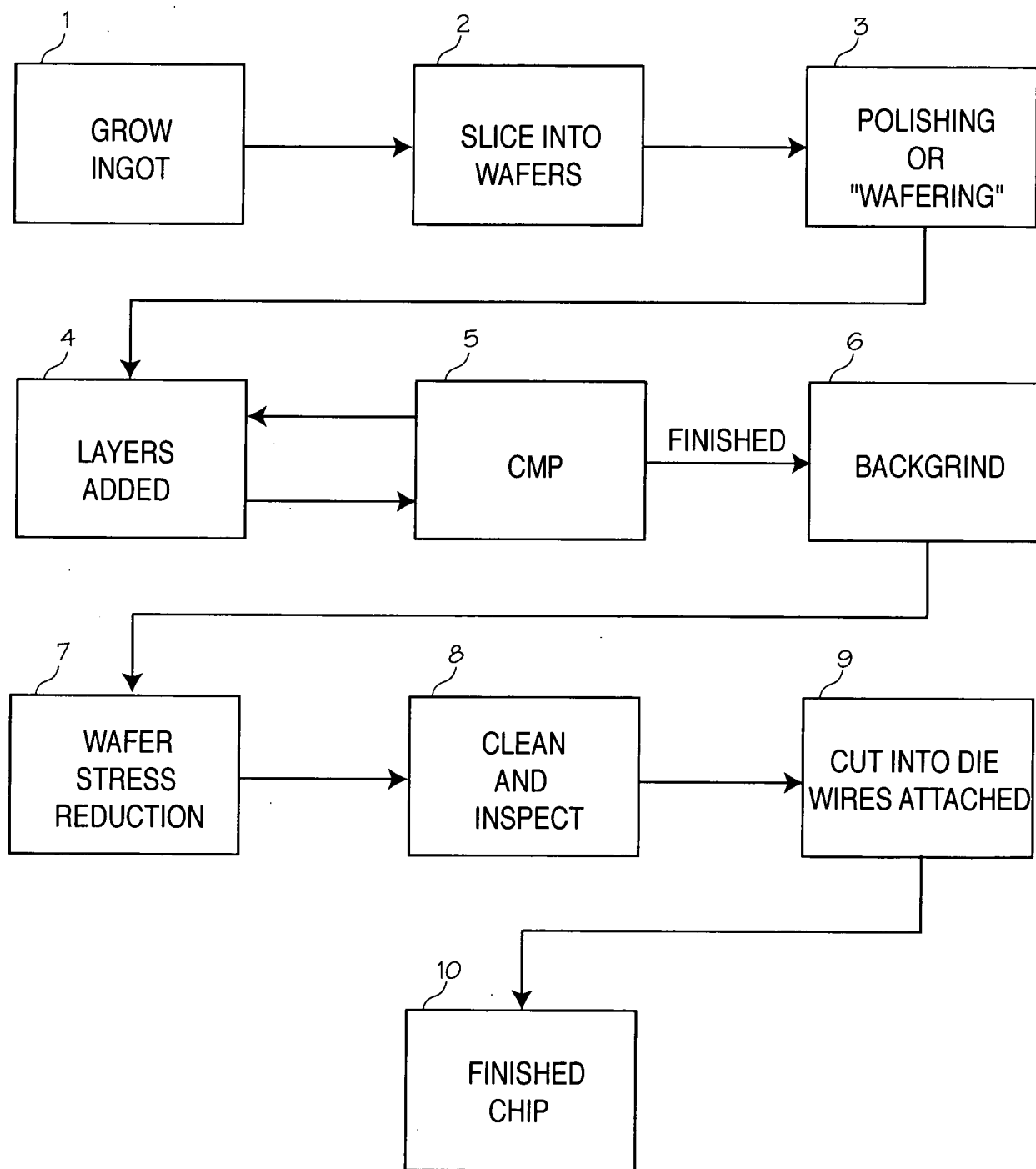
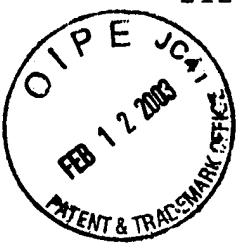


Fig. 1





2/4

Fig. 2

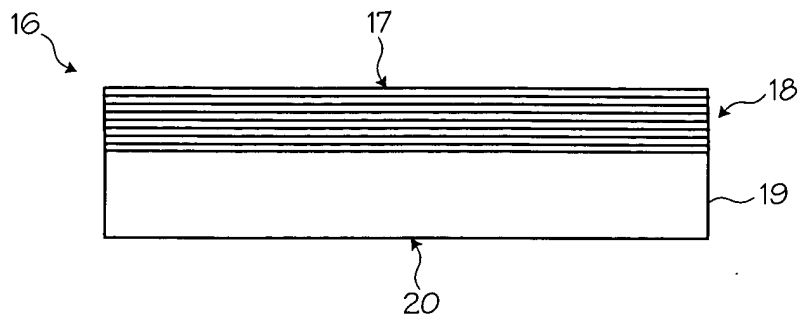


Fig. 3

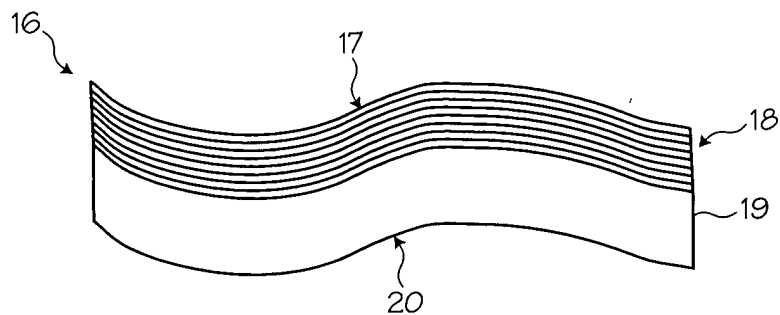


Fig. 4a

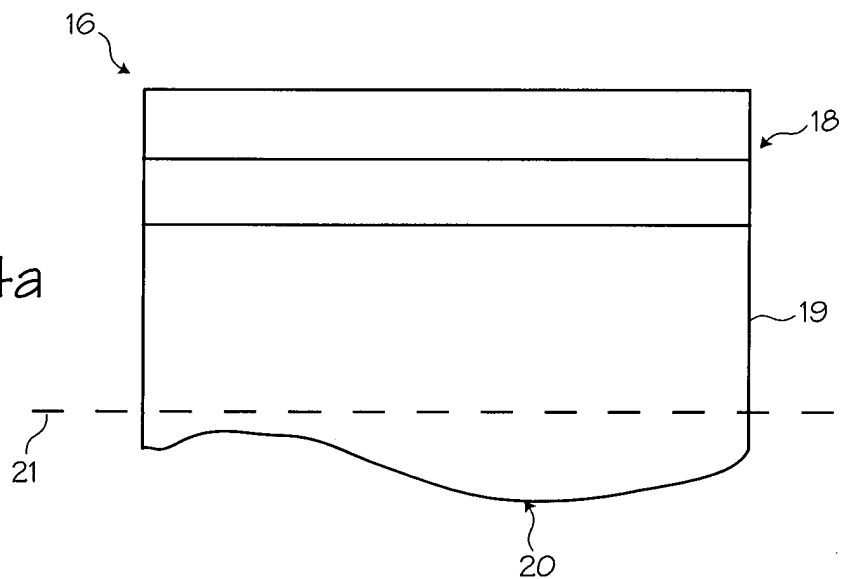
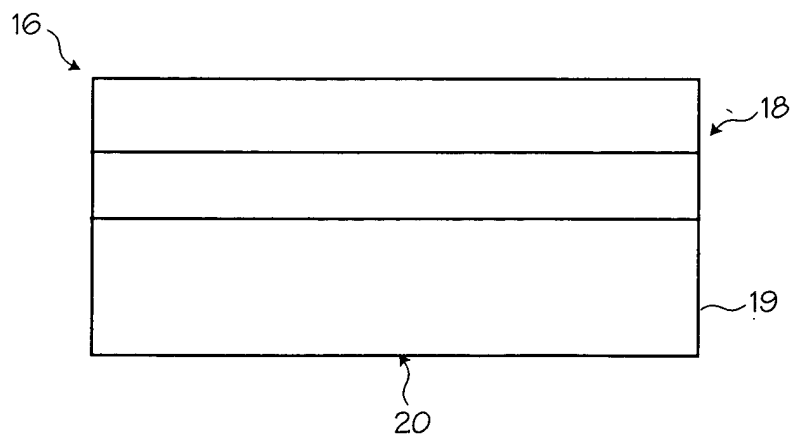


Fig. 4b



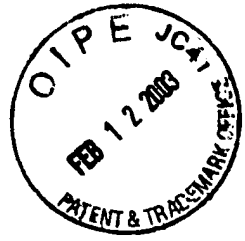


Fig. 5

3/4

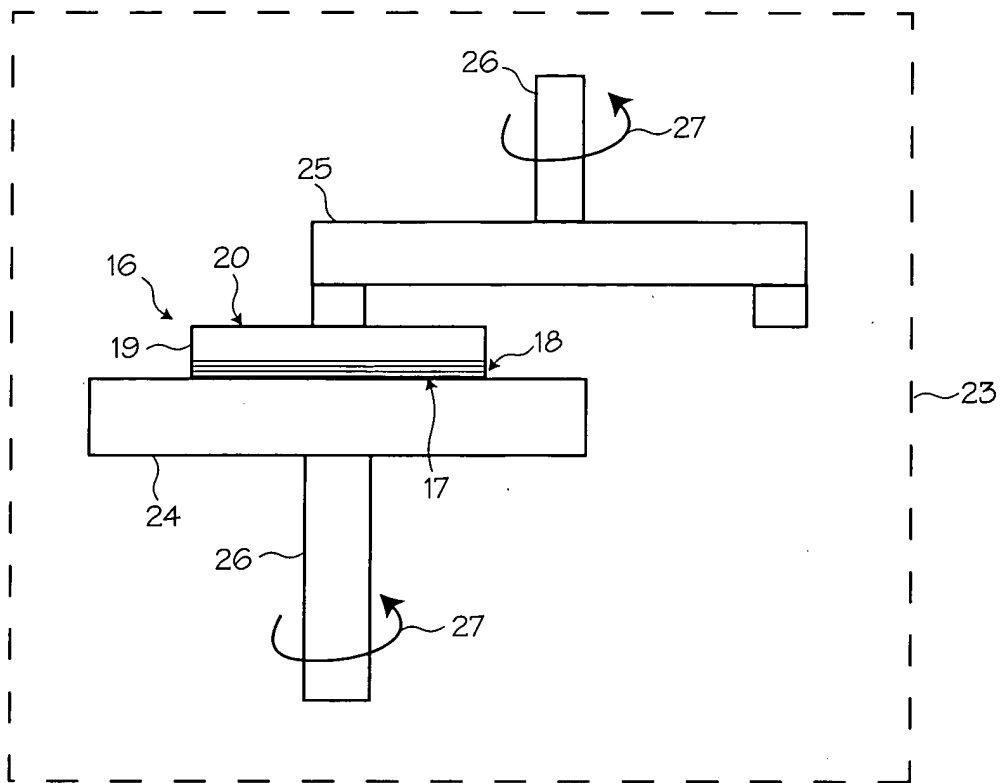
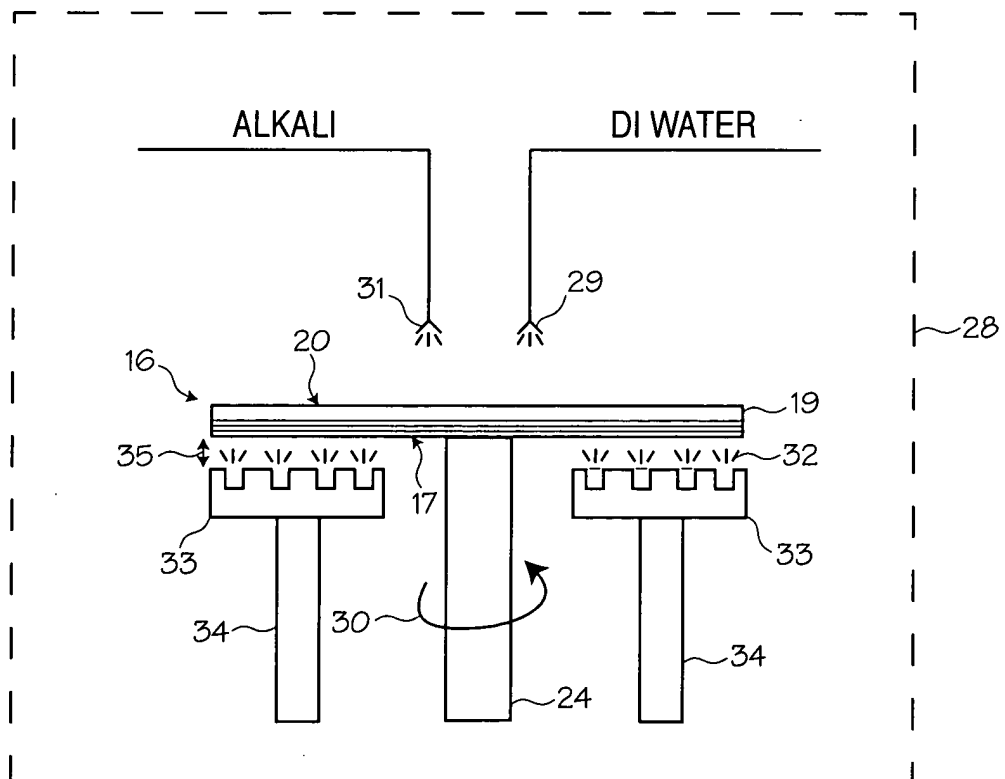


Fig. 6



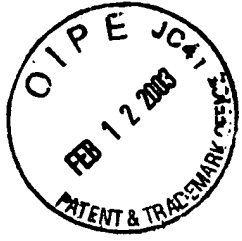


Fig. 7

